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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TADAHIRO OHMI, ET AL.

Application No.: 09/425,015

Filed: October 25, 1999

For: GAS SUPPLY PATH
STRUCTURE, GAS SUPPLY
METHOD, LASER
OSCILLATING
APPARATUS, EXPOSURE
APPARATUS, AND DEVICE
PRODUCTION METHOD

Examiner: Davienne Monbleau

Group Art Unit: 2874

May 13, 2002

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT AND PETITION FOR EXTENSION OF TIME

Sir:

Applicants' petition to extend the time for response to the Office Action dated December 12, 2001 from March 12, 2002 to May 12, 2002 (Sunday). A check in the amount of \$400.00 for payment of the extension fee is enclosed. Please charge any

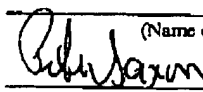
I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on

May 13, 2002

(Date of Deposit)

Peter Saxon

(Name of Attorney for Applicant)



(Signature)

May 13, 2002

(Date of Signature)